



AF/1700
AMAT Docket No. 2616 US/RTP/LE
BSTZ Docket No. 004887.P090

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Guangcai Xing, et al.

Application No. 09/298,064

Filed: April 22, 1999

For: APPARATUS AND METHOD FOR EXPOSING A
SUBSTRATE TO PLASMA RADICALS

Examiner: Zervigon, R.

Art Unit: 1763

NOTICE OF APPEAL

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Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicants hereby appeal the final rejection of Claims 1-7 and 17-20 in an Office Action mailed June 4, 2001 as supplemented in an Advisory Action mailed October 18, 2001.

Also, submitted herewith is the fee required by 37 C.F.R. 1.17(e) in the amount of \$320.00. Please credit any overpayment or charge any additional amount due to Deposit Account 02-2666. A duplicate of the Fee Transmittal sheet is submitted herewith for charging purposes.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN, LLP

Dated: 11/5/01

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CERTIFICATE OF MAILING:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231 on November 5, 2001.

Nedy Calderon

Date

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